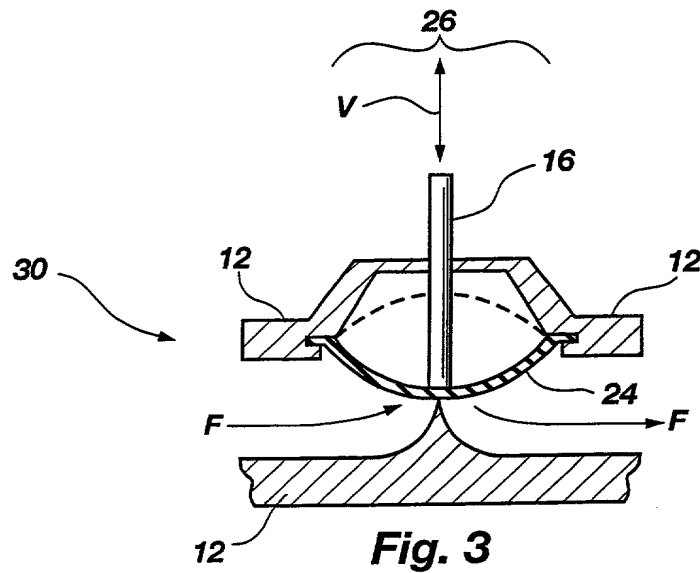
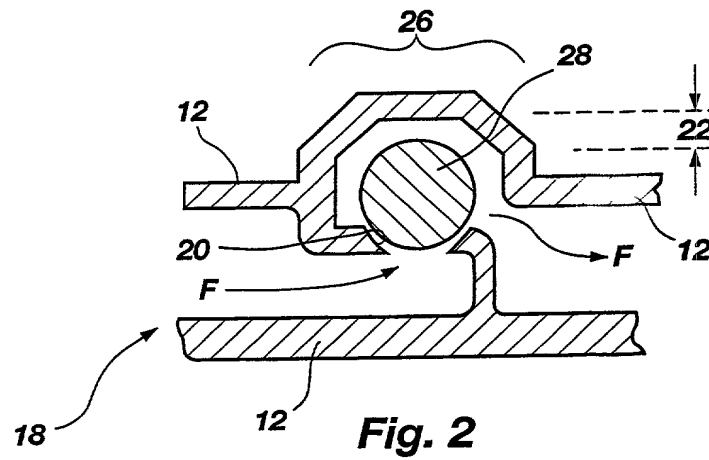
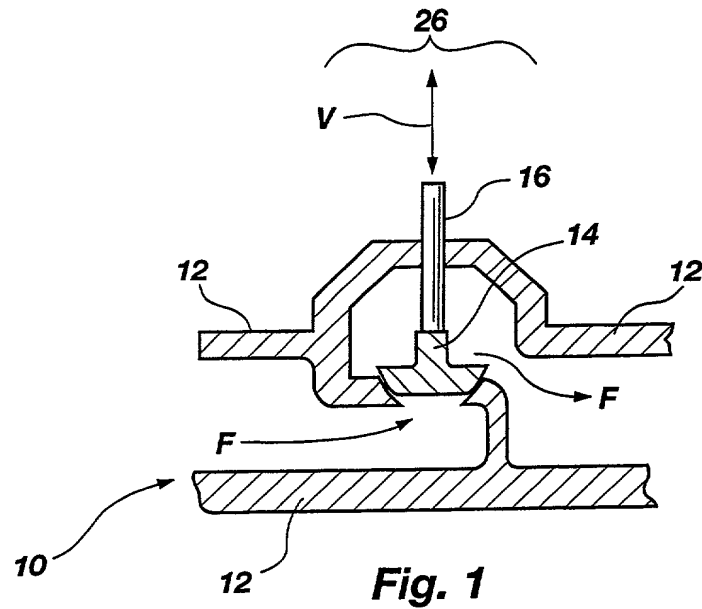


1/3



2/3

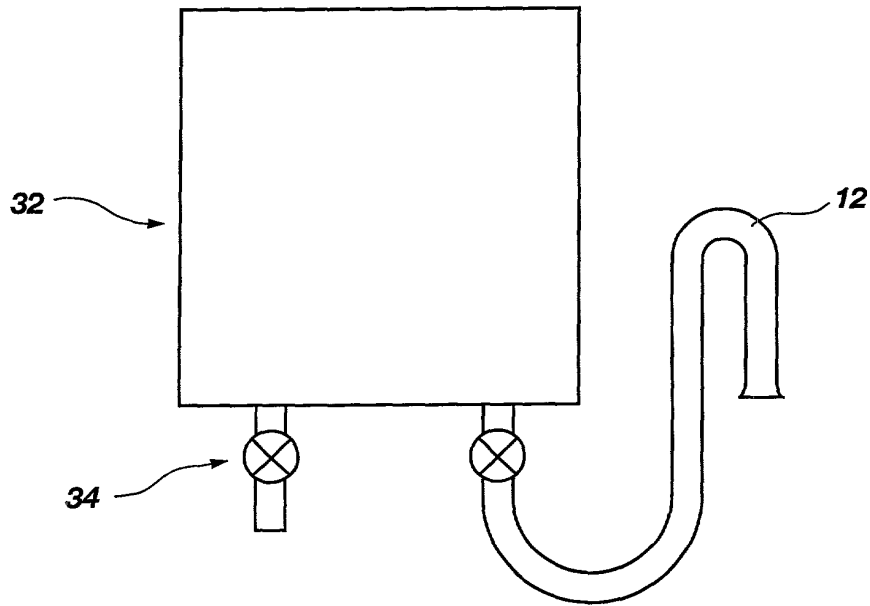


Fig. 4

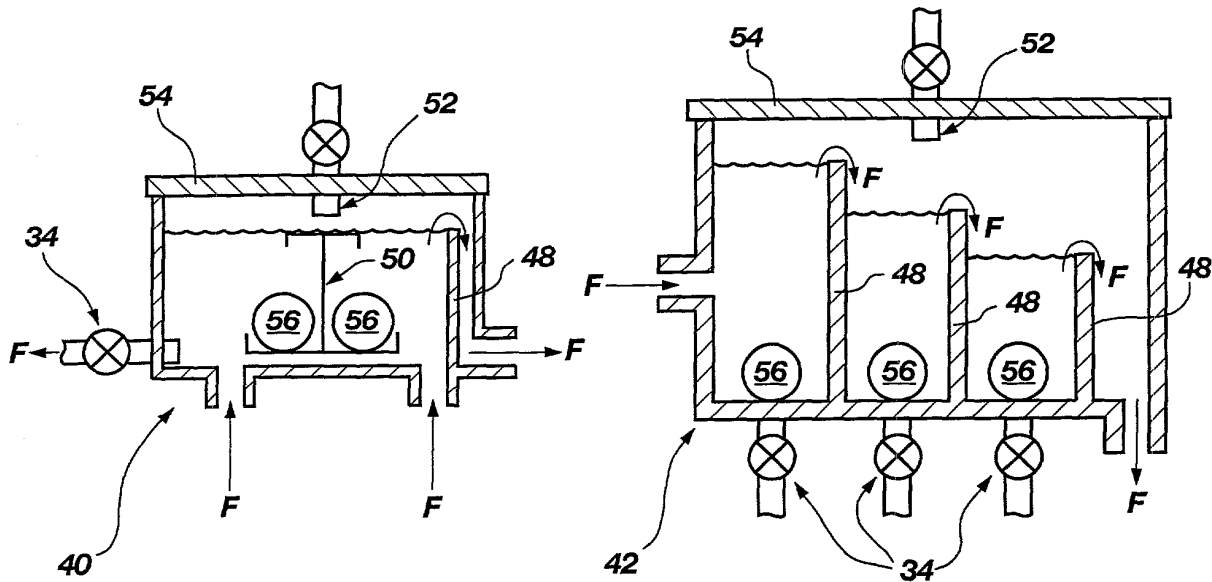


Fig. 5

Fig. 6

TITLE: METHOD OF REDUCING WATER SPOTTING AND
OXIDE GROWTH ON A SEMICONDUCTOR STRUCTURE

Inventor: Donald L. Yates
Serial No.: Not yet assigned
Docket No.: 3375.6US (95-0999.4)

3/3

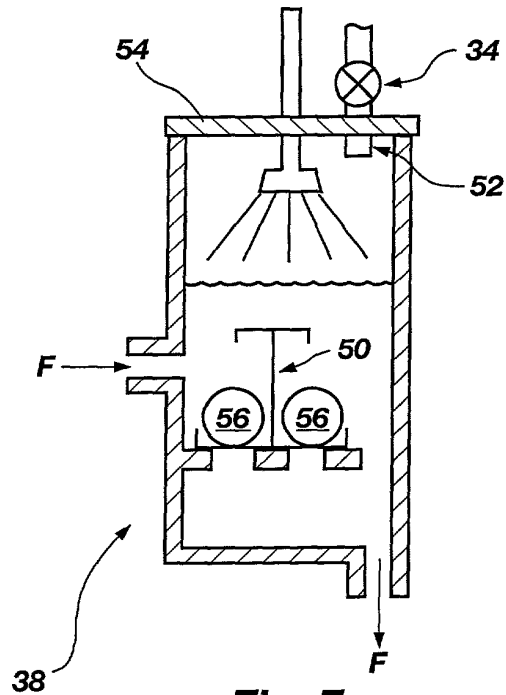


Fig. 7

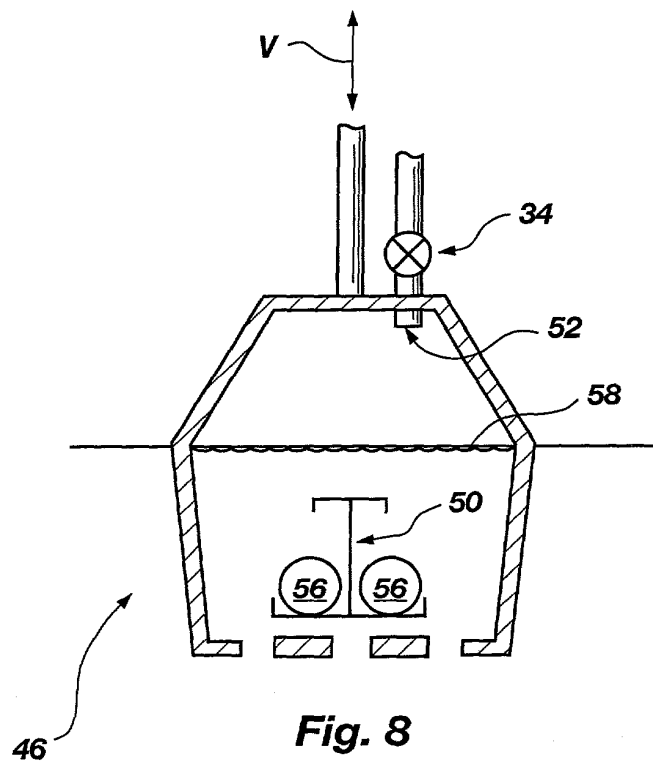


Fig. 8